

In re the Application of:

Reiki WATANABE

Serial No.: 10/743,314

Filed: December 23, 2003

For: PROCESSING EQUIPMENT AND PROCESSING METHOD

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97(b)(1)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

It is respectfully requested that the examiner consider and cite of record the six (6) documents listed on the attached. Copies of the two Japanese language documents, published English language abstracts thereof, and a copy of the literature article by Tuomo Suntola are also submitted herewith.

Respectfully submitted,

Reg. No. 25,814

Dated: February 4, 2004

LORUSSO, LOUD & KELLY 3137 Mount Vernon Avenue Alexandria, VA 22305

(703) 739-9393

INFORMATION DISCLOSURE CIPATION 'S						Docket Number (Optional)	Application Number 10/743,314				
						OKA-C387 Applicant(s)					
		(Use several sheets if necess	gfry)	Reiki WATANABE						
•				FEB 0 4 2004		Filing Date 12/23/03		Group Art Unit			
FRAMENTS PROCESS. PATENT DOCUMENTS											
EXAMINER INITIAL	REF DOCUMENT NU		DOCUMENT NUMBER	DATE		NAME	CLASS	SUBCLASS	FILING DATE . IF APPROPRIATE		
		5,87	9,459	3/9/99	GADGIT et al		118 715		4		
		6,174,377		1/16/01	DOERING et al		118 729				
		6,38	7,185	5/14/02	DOERING et al		118 729				
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FOREIGN PATENT DOCUMENTS											
	REF		DOCUMENT NUMBER	DATE		COUNTRY	CLASS	SUBCLASS	Translation		
		2002-4054		1/0/02	TD.	·			YES NO		
				1/9/02	JP 						
		2001-348666		12/18/01	JP						
			: <u>-</u>							· -	
	OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)										
Handbook of Thin Film Process Technology, B1.5:1-B1.5.17, 1995 IOP Publishing Ltd.										·	
			·								
EXAMINER						DATE CONSIDERED					
						ce with MPEP Section 609; D	raw line thro	ugh citation if not	in conform	ance and	
not considered. Include copy of this form with next communication to applicant.											

Form PTO-A820 (also form PTO-1449)